

Amendments to the Claims:

1. (Currently Amended) A ~~sensor~~ heater system capable of self-sensing its own temperature, comprising:

an AlN substrate,
a W layer on said substrate,
a signal source adapted to apply an electrical actuating signal to heat said W layer, and
a sensor adapted to sense the response of said W layer to said actuating signal as an indication of the temperature of said W layer, said W layer having a response to said actuating signal which varies with the W layer's temperature.

2. (Original) The system of claim 1, said W layer comprising a thin film.

3. (Original) The system of claim 1, further comprising an oxidation resistant protective layer on said W layer.

4. (Currently Amended) A sensor The system of ~~claim 3, said~~ comprising:

an AlN substrate,
a W layer on said substrate,
an oxidation resistant gold, Au-Pt alloy or Pt
protective layer comprising gold on said W layer,
a signal source adapted to apply an electrical
actuating signal to said W layer, and
a sensor adapted to sense the response of said
W layer to said actuating signal.

5. (Original) The system of claim 3, said protective layer comprising B_2O_3 - SiO_2 .

6. (Cancelled)

7. (Currently Amended) The system of claim 6 4, said protective layer ~~further~~ comprising an Au-Pt alloy with W on said Au-Pt alloy.

8. (Currently Amended) The system of claim 6 4, said protective layer ~~further~~ comprising an Au-Pt alloy with B₂O₃-SiO₂ on said Au-Pt alloy.

9. (Cancelled)

10. (Currently Amended) The system of claim 9 4, said protective layer further comprising Pt with B₂O₃-SiO₂ on said Pt.

11. (Original) The system of claim 3, further comprising an AlN cap on said protective layer.

12. (Original) The system of claim 1, said W layer comprising a plurality of conductive strands distributed on said substrate.

13. (Original) The system of claim 12, wherein said strands are generally parallel and serpentine shaped.

14. (Original) The system of claim 13, wherein said substrate is rectangular.

15-18. (Cancelled)

19. (Currently Amended) The system of

claim ~~10~~ 1, further comprising an additional AlN substrate with an additional W layer thereon, said signal source connected to apply a substantially non-heating electrical signal to said additional W layer, and a sensor connected to sense a response of said additional W layer as an indication of its temperature,

said additional substrate and additional W layer disposed downstream of said substrate and conductive layer in a fluid flow path, with the difference in temperature between said W and additional W layers corresponding to the fluid flow rate.

20. (Currently Amended) The system of claim 1, said substrate and W layer disposed in a fluid flow path, ~~said signal source being controllable to apply an actuating signal which heats said W layer, with~~ said response sensed by said sensor corresponding to a fluid flow rate along said path.

21-23. (Cancelled)

24. (Currently Amended) A heater system capable of self-sensing its own temperature, comprising:

an AlN substrate,

a conductive layer on said substrate which, over a predetermined temperature operating range, has an expansion coefficient within 1.00 ± 0.07 of said substrate, is substantially non-reactive with said substrate, and exhibits substantially no solid-solubility or interdiffusivity with said substrate,

a signal source adapted to apply an electrical actuating signal to heat said conductive layer, and

a sensor adapted to sense the response of said conductive layer to said actuating signal as an indication of the temperature of said conductive layer, said

conductive layer having a response to said actuating signal which varies with the conductive layer's temperature.

25. (Original) The system of claim 24, said conductive layer comprising a thin film.

26. (Original) The system of claim 24, further comprising an oxidation resistant protective layer on said conductive layer.

27. (Original) The system of claim 26, further comprising an AlN cap on said protective layer.

28. (Original) The system of claim 24, said conductive layer comprising a plurality of conductive strands distributed on said substrate.

29. (Original) The system of claim 28, wherein said strands are generally parallel and serpentine shaped.

30. (Original) The system of claim 29, wherein said substrate is rectangular.

31-34. (Cancelled)

35. (Currently Amended) The system of claim ~~34~~ 24, further comprising an additional AlN substrate with an additional conductive layer thereon, said signal source connected to apply a substantially non-heating electrical signal to said additional conductive layer, and a sensor connected to sense a response of said additional conductive layer as an indication of its temperature,

said additional substrate and additional

conductive layer disposed downstream of said substrate and conductive layer in a fluid flow path, with the difference in temperature between said conductive layer and additional conductive layer corresponding to the fluid flow rate.

36. (Currently Amended) The system of claim 24, said substrate and conductive layer disposed in a fluid flow path, ~~said signal source being controllable to apply an actuating signal which heats said conductive layer, with said response sensed by said sensor corresponding to a fluid flow rate along said path.~~

37-39. (Cancelled)

40. (Currently Amended) A ~~sensor~~ heater system capable of self-sensing its own temperature, comprising:

an insulative substrate,

a W conductive layer on said substrate which, over a predetermined temperature operating range, has an expansion coefficient within 1.00 ± 0.07 of said substrate, is substantially non-reactive with said substrate, and exhibits substantially no solid-solubility or interdiffusivity with said substrate,

a signal source adapted to apply an electrical actuating signal to heat said W layer, and

a sensor adapted to sense the response of said ~~conductive~~ W layer to said actuating signal as an indication of the temperature of said W layer, said W layer having a response to said actuating signal which varies with the W layer's temperature.

41. (Original) The system of claim 40, said W layer comprising a thin film.

42. (Currently Amended) The system of claim 40, further comprising an oxidation resistant protective layer on said ~~conductive~~ W layer to inhibit oxidation of said conductive layer.

43. (Original) The system of claim 42, further comprising an AlN cap on said protective layer.

44. (Currently Amended) The system of claim 40, said ~~conductive~~ W layer comprising a plurality of conductive strands distributed on said substrate.

45. (Original) The system of claim 44, wherein said strands are generally parallel and serpentine shaped.

46. (Original) The system of claim 45, wherein said substrate is rectangular.

47-50. (Cancelled)

51. (Currently Amended) The system of claim ~~50~~ 40, further comprising an additional insulative substrate with an additional W conductive layer thereon, said signal source connected to apply a substantially non-heating electrical signal to said additional conductive layer, and a sensor connected to sense a response of said additional conductive layer as an indication of its temperature,

said additional substrate and additional conductive layer disposed downstream of said substrate and conductive layer in a fluid flow path, with the difference in temperature between said conductive layer and additional conductive layer corresponding to the fluid flow rate.

52. (Currently Amended) The system of claim 40, said substrate and conductive layer disposed in a fluid flow path, ~~said signal source being controllable to apply an actuating signal which heats said conductive layer,~~ with said response sensed by said sensor corresponding to a fluid flow rate along said path.

53-69. (Cancelled)

70. (New) A heater, comprising:
a rectangular AlN substrate, and
a plurality of generally parallel and serpentine shaped W conductive strands on said substrate, wherein the widths of said strands are not more than 0.25 cm, the spacing between strands is not more than 0.18 cm, the peak-to-valley distance of the strands perpendicular to the strand conduction path is more than the strand widths, and the distance between the strand peaks and valleys parallel to the strand conduction path is not more than 2.5 cm.

71. (New) The heater of claim 70, wherein the thickness of said substrate is not more than 0.36 cm.

72. (New) The heater of claim 71, wherein the thickness of said substrate is within the range of 0.025-0.036 cm.